

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
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Se-Jin CHUNG)	
)	
Application No.: Divisional of 09/965,844)	Group Art Unit: 1765
)	
Filed: October 21, 2003)	Examiner: F. Hiteshew
)	
For: EXCIMER LASER CRYSTALLIZATION)	Mail Stop Patent Application
OF AMORPHOUS SILICON FILM)	

Commissioner for Patents
U.S. Patent and Trademark Office
2011 South Clark Place
Customer Window, **Mail Stop Patent Application**
Crystal Plaza Two, Lobby, Room 1B03
Arlington, VA 22202

Sir:

PRELIMINARY AMENDMENT

Prior to the examination of the above-identified application on the merits, please amend
the application as follows: